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E. Hillis
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PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Toshikazu INOUE et al.**

Serial Number: **Not Yet Assigned**

Filed: **December 29, 1999**

For: **SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING
THE SAME**

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

December 29, 1999

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

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Respectfully submitted,
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Enclosures: PTO-1449; References (5).